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[10191/1811]

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5/22/03**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s) : BREITSCHWERDT et al.
Serial No. : 09/871,224
Filed : May 31, 2001
For : DEVICE AND METHOD FOR ETCHING A
SUBSTRATE BY USING AN INDUCTIVELY
COUPLED PLASMA
Examiner : Binh X. TRAN
Art Unit : 1765

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Mail Stop Non-Fee Amendment
Commissioner for Patents
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05/21/2003 HASFAW1 00000094 110600 09871224
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I hereby certify that this correspondence is being deposited with the
United States Postal Service with sufficient postage as first class mail
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Date: 5/15/03 Reg. No. 35,952
Signature: *[Signature]*

RESPONSE TO RESTRICTION REQUIREMENT

SIR:

In the Office Action dated March 17, 2003, the Examiner required restriction
to one of the following inventions:

Group I - Claims 1-9, 20
Group II - Claims 10-19

Accordingly, applicants hereby elect, without traverse, the claims of Group I,
i.e., claims 1-9, 20.

Applicants respectfully request a one-month extension of time in which to
respond to the Office Action dated March 17, 2003, for which a response period
expiring on April 17, 2003 was set. The extended period expires on
May 17, 2003.

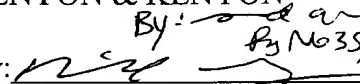
Please charge the \$110.00 extension fee and any additional fees
required to Deposit Account No. 11-0600. A duplicate copy of this Transmittal is
enclosed.

An early and favorable action on the merits is earnestly solicited.

Respectfully submitted,

KENYON & KENYON

Dated: 5/15/03

By: 
 By No 35,952

Richard L. Mayer
Reg. No. 22,490

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